

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1751**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Miho WATANABE et al.

Group Art Unit: 1751

Application No.: 10/765,927

Examiner: J. THOMAS

Filed: January 29, 2004

Docket No.: 118484

For: RESISTANCE ELEMENT, METHOD OF MANUFACTURING THE SAME, AND
THERMISTOR

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the September 26, 2006, Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.

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enter
JT
2/5/2007*